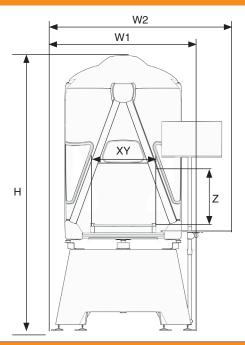
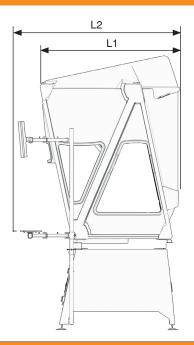


## Equator-X<sup>™</sup> 500





Dimensions (mm)							
XY		z	W1	W2	L1	L2	н
Ø 500	)	250	1188	1250	1228	1452	2390

Environmental specifications		
Indoor use	Machine: IPX0 IEC 60529 (indoor use only) Base: IPx2* (sealed against liquid coming from parts on the transfer system)	
Operating temperature	+5 °C to +50 °C	
Storage temperature	-25 °C to +70 °C	
Humidity	Maximum 80% RH at 40 °C, non-condensing	

Specifications		
Weight of machine	140 kg	
Weight of base	50 kg	
Fixture plate	510 mm × 510 mm	
Maximum part weight including fixturing - MTS locked static or no MTS	100 kg	
Maximum part weight including fixturing - with MTS operating	25 kg	
Thread size	Bed inserts are M8 (M6 and 1/4" fixture plates are available)	
Supported probe	SP25M with SM25-2 (scanning and touch points)	
Stop circuit	Safety category: CAT 2-PL-b ISO 13849-1: B ISO 13850: 1 - controlled stop and power removed	
Joystick	MCU lite-2	
Control system	Equator motion controller (MC)	
Position measurement	Renishaw RESOLUTE absolute optical encoder system	





## Absolute measurement performance

Criteria	Performance	Temperature range
Length measurement error E0 (1) & E60 (2)	± (2.1 + L/300) μm <sup>(3)</sup>	18 - 22 °C
ISO 10360-2:2009	± (2.6 + L/180) μm <sup>(3)</sup>	18 - 26 °C

Criteria	Performance	Details
Repeatability range of the length measurement error ISO 10360-2:2009	1.2 μm	Repeatability of E0 MPL (maximum limit)
Scanning mode test ISO 10360-5:2020	Form: 2.9 µm Size: 1.2 µm Time: 40 seconds <sup>(4)</sup>	MPE(P[Form.Sph.Scan:NPP:Tact]) MPE(P[Size.Sph.Scan:NPP:Tact]) MPE(t[Sph.Scan:NPP:Tact])
Single stylus probing test ISO 10360-5:2020	Form: 2.4 µm Size: 1.2 µm	MPE(P[Form.Sph.1x25:SS:Tact]) MPE(P[Size.Sph.1x25:SS:Tact])
Multi stylus test ISO 10360-5:2020	Form: 3.9 µm Size: 1.2 µm Location: 2.7 µm	MPE(P[Form.Sph.5x25:MS:Tact]) MPE(P[Size.Sph.5x25:MS:Tact]) MPE(L[Dia.5x25:MS:Tact])
Ring gauge scanning form <sup>(7)</sup> ISO 10360-5:2020 Annex A.6	Up to 50 mm/s: 2.4 μm Up to 250 mm/s <sup>(5)</sup> : 5 μm	MPE(P[Form.Cir.Scan:NPP.0:Tact]) 50 mm/s – 250 mm/s <sup>(6)</sup> : 0.013v + 1.75 μm <sup>(6)</sup>
Ring gauge scanning size (7) ISO 10360-5:2020 Annex A.6	Up to 50 mm/s: 1.2 μm Up to 250 mm/s <sup>(5)</sup> : 2.16 μm	MPE(P[Size.Cir.Scan:NPP.0:Tact]) 50 mm/s – 250 mm/s <sup>(5)</sup> : 0.0048v + 0.96 μm <sup>(6)</sup>

- (1) E0: Acceptance test with SM25-2 module; stylus length of 26 mm and stylus tip diameter of 8 mm
- (2) E60: Acceptance test with SM25-2 module; stylus length of 60 mm and stylus tip diameter of 8 mm
- (3) Where L is distance measured in mm
- (4) Completed at scan speed of 75 mm/s
- (5) Scan velocity limited to 250 mm/s or 1 rev/s, whichever is lower
- (6) Where v is the scan velocity in mm/s.
- (7) Using a 50 mm ring gauge, 50 UPR filter, SM25-2 with 5x21 stylus, near to calibration location in the centre of the machine volume.

Specifications		
Travel speed (maximum)	750 mm/s vector velocity	
Acceleration (maximum)	1500 mm/s² vector acceleration	
Scan speed (maximum)	250 mm/s or 1 rev/s - Max speed dependant on feature size	
Warm up time	2 hours (until absolute specification applies)	
Temperature gradient	2 °C per hour 8 °C per day	
Temperature compensation	Compensation for steady state and varying temperature up to 2 °C/hour.	

## **Comparator performance**

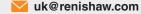
Specifications		
Travel speed (maximum)	750 mm/s vector velocity	
Acceleration (maximum)	1500 mm/s² vector acceleration	
Scan speed (maximum)	500 mm/s or 2 rev/s - Max speed dependant on feature size	
Comparison uncertainty	± 2 μm	

<sup>\*</sup> The process of comparator measurement on an Equator-X system involves defining a series of gauge points on the component surface. Periodic calibration of a master part either using the absolute measurement method on the Equator-X system or on a separate CMM establishes datum values for each gauge point. The same gauge points on the same master part are measured on the Equator-X system, - 'mastering' -, to establish a correlation with the certified accuracy of the Equator-X system or separate CMM. Subsequently, a regular 're-mastering' process is used to account for changing environmental conditions. Size and position measurements made immediately following re-mastering will have a comparison uncertainty of  $\pm 0.002$  mm relative to the certified measurements of the master part. This specification applies where each part is fixtured to within 1 mm relative to the master part.

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